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GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kuei-Jen Chang

Group Art Unit: 1763

Serial No.: 09/822,749

Examiner: Mulero Luz L. Alejandro

Filed: March 30, 2001

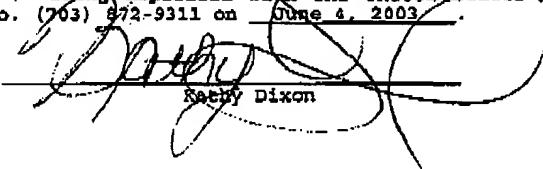
In Response to Office Action

Dated: April 4, 2003

For: Method and Apparatus for In-Situ Descum/Hot Bake/Dry
Etch Photoresist/Polyimide Layer

Attorney Docket No.: 67,200-397

Certificate of Facsimile
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 672-9311 on June 4, 2003.


Betty DixonREQUEST FOR RECONSIDERATIONCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to a final Office Action mailed April 4, 2003, please consider the following remarks.